

S/N 08/903,486

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Leonard Forbes et al.

Examiner: W. Mintel

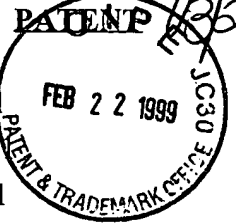
Serial No.: 08/903,486

Group Art Unit: 281

Filed: July 29, 1997

Docket: 303.326US1

Title: SILICON CARBIDE GATE TRANSISTOR AND FABRICATION PROCESS



RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

In response to the Restriction Requirement mailed January 27, 1999, Applicant provisionally elects, without traverse, Group I (claims 1-15). Applicant respectfully cancels remaining claims 16-21 without prejudice, and reserves the right to reintroduce them in a divisional application at a later date.

The Examiner is invited to contact Applicants' Representatives at the below-listed telephone number if there are any questions regarding this Response or if prosecution of this application may be assisted thereby.

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Respectfully submitted,

LEONARD FORBES ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
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Date

Feb. 18, 1999

By

Daniel J. Kluth

Daniel J. Kluth

Reg. No. 32,146

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Assistant Commissioner of Patents, Washington, D.C. 20231 on February 18, 1999.

Name

Daniel J. Kluth

Signature

Daniel J. Kluth